

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)

Shunpei YAMAZAKI et al.)

Serial No. 09/535,015)

Filed: March 24, 2000)

For: METHOD OF MANUFACTURING)

A SEMICONDUCTOR DEVICE)

) Group Art Unit: 2811

) Examiner: S. Crane

#10
Election
FJONES
8-2-02

CERTIFICATE OF MAILING

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RESPONSE TO ELECTION REQUIREMENT

Honorable Commissioner for Patents


Washington, D.C. 20231

Sir:

In response to the election requirement in the Office Action of June 18, 2002, Applicants hereby elect with traverse species I, a semiconductor film containing hydrogen or halogen. Claims 2-14 and 21 are readable thereon. Furthermore, Applicants note that independent claim 29 recites a semiconductor film containing a hydrogen and independent claim 35 recites a semiconductor film containing a halogen. Thus, it is believed that claims 29-43 should also be examined with species I.

Examination on the merits is requested.

Respectfully submitted,


Eric J. Robinson
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